JAP5 Rec'd PCT/PTO 28 SEP 2006

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OF 10/594844

In re application of

Docket No: O97404

Akira OHUCHI, et al.

Appln. No.: Not assigned yet

Group Art Unit: Not assigned yet

Confirmation No.: Not assigned

Examiner: Not assigned yet

Filed: September 28, 2006

For: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §§ 1.97 and 1.98

MAIL STOP AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure under 37 C.F.R. § 1.56, Applicants hereby notify the U.S. Patent and Trademark Office of the documents which are listed on the attached PTO/SB/08 A & B (modified) form and/or listed herein and which the Examiner may deem material to patentability of the claims of the above-identified application.

- 1. Japanese Patent Application Publication No. 2001-332583, published November 30, 2001, along with English-Language Abstract.
- 2. Japanese Patent Application Publication No. 2002-057186, published February 22, 2002, along with English-Language Abstract;
- 3. Japanese Patent Application Publication No. 2004-103928, published April 2, 2004, along with English-Language Abstract;

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- 4. Japanese Patent Application Publication No. 2003-179100, published June 27, 2003, along with English-Language Abstract;
- 5. Japanese Patent Application Publication No. 2002-343829, published November 29, 2002, along with English-Language Abstract;
- 6. Japanese Patent Application Publication No. 2000-138255, published May 16, 2000, along with English-Language Abstract and

One copy of each of the listed documents is submitted herewith.

The present Information Disclosure Statement is being filed: (1) No later than three months from the application's filing date; (2) Before the mailing date of the first Office Action on the merits (whichever is later); or (3) Before the mailing date of the first Office Action after filing a request for continued examination (RCE) under §1.114, and therefore, no Statement under 37 C.F.R. § 1.97(e) or fee under 37 C.F.R. § 1.17(p) is required.

In compliance with the concise explanation requirement under 37 C.F.R. § 1.98(a)(3) for foreign language documents, Applicants state that reference 1 is cited within the specification beginning at page 6, line 26. Applicants also enclose herewith a copy of an International Search Report citing document 2-6, indicating the degree of relevance found by the foreign patent office.

The submission of the listed documents is not intended as an admission that any such document constitutes prior art against the claims of the present application. Applicant does not waive any right to take any action that would be appropriate to antedate or otherwise remove any listed document as a competent reference against the claims of the present application.

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The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,

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Date: September 28, 2006

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

of

IAPS RECOMPLIFITO 28 SEP 2006					
Application Number	Not assigned yet				
Confirmation Number	Not assemed yet O h. O h. R				
Filing Date	September 28, 2006				
First Named Inventor	Akira OHUCHI				
Art Unit	Not assigned yet				
Examiner Name	Not assigned yet				
Attorney Docket Number	Q97404				

			U.S. I	PATENT DOCUME	ENTS
Examiner Initials*	Cite No.1	Document Number		Publication Date	
		Number	Kind Code ² (if known)	MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		US			

FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No.1	Foreign Patent Document			Publication Date	Name of Patentee or	
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)	MM-DD-YYYY	Applicant of Cited Document	Translation ⁶
		JP	2001-332583	Α	11-30-2001		
		JP	2002-057186	Α	02-22-2002		
		JP	2004-103928	Α	04-02-2004		
		JP	2003-179100	Α	06-27-2003		
		JP	2002-343829	Α	11-29-2002		
		JP	2000-138255	A	05-16-2000		

		NON PATENT LITERATURE DOCUMENTS			
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Examiner Signature	Date Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or follow the hyperlink from the title of the document to the intranet. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to indicate here if English language Translation is attached.